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PNET.009D

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION of

Tsukasa Yajima

Group Art Unit: 2814

Serial No.: 09/768,271

Examiner: A. Mai

Filed: January 25, 2001

For: SEMICONDUCTOR DEVICE HAVING PROTECTIVE LAYER ON FIELD OXIDE

AMENDMENT UNDER 37 C.F.R. 1.116

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Date: May 12, 2003  
(Monday)

Sir,

In response to the Final Office Action dated January 10, 2003, the period for response having been extended one month to May 10, 2003, the following amendments and remarks are respectfully submitted in connection with the above-identified application.

In the Drawings:

Please cancel Fig. 1(i). ✓

In the Specification:

Replace the paragraph beginning on page 13, line 12 with the following paragraph:

"Thereafter, the side-wall 37 is formed by implementing the anisotropic etching

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#16 E Just  
M. Brown  
5/16/03